





IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

pplicants:

T. KAWAGUCHI et al

Serial No.:

10/688,991

Filed:

October 21, 2003

For:

PLASMA PROCESSING METHOD AND APPARATUS

Group:

3742

INFORMATION DISCLOSURE STATEMENT **UNDER 37 CFR 1.97 & 1.98**

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

September 10, 2004

Sir:

In the matter of the above-identified application, applicant(s) is/are submitting herewith a copy of a document listed in the attached form equivalent to Form PTO-1449 for the Examiner's consideration, it being noted that such document was cited in parent application Serial No. 10/083,252.

This information disclosure statement is being submitted before the mailing date of a first office action on the merits and with the following certification specified in 37 CFR 1.97(e).

On information and belief, each item of information contained in this information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

To the extent that, the documents listed on the attached form equivalent to Form PTO-1449, are not in the English language, the requirement of 37 CFR

1.98(a)(3) for a concise explanation of the relevance is satisfied by an English language translation of the document.

It is respectfully requested that this information disclosure statement be considered by the Examiner.

Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account No. 01-2135 (500.41295VX1) and please credit any excess fees to such deposit account.

Respectfully submitted,

Melvin Kraus

Registration No. 22,466

ANTONELLI, TERRY, STOUT & KRAUS, LLP

MK/cee Attachments (703) 312-6600 Form PTO-1449 Equivalent

U.S. Department of Commerce Patent and Trademark Office

Atty. Docket No. 500.41295VX1

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U.S. Patent Documents

Examiner Initials	Document No.	Date	Name	Class Subclass	Filing Date If Approp.

Foreign Patent Documents

Document No.	Date	Country	Class Subclass	Translation Yes No
2000-323298	11/00	Japan		×

Other Documents (including Author, Title, Date, Pertinent Pages, etc.)

Examiner

Date Considered

^{*}Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.